



Attorney Docket: 021906-0307405
Client Reference: PLA31178/DBE/US-HO

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
LEE

Confirmation Number: 9617

Application No.: 10/743,454

Group Art Unit: 2823

Filed: December 23, 2003

Examiner: Estrada, Michelle

Title: METHOD FOR PLANARIZING A SURFACE OF A SEMICONDUCTOR WAFER

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 25, 2004, the following Remarks are made.

12/23/2004 SHINASS1 00000107 033975 10743454
01 FC:1251 120.00 DA